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# Sign reversal of anisotropic magnetoresistance and anomalous thickness-dependent resistivity in $\text{Sr}_2\text{CrWO}_6/\text{SrTiO}_3$ films

Chunli Yao(姚春丽)<sup>1</sup>, Tingna Shao(邵婷娜)<sup>1</sup>, Mingrui Liu(刘明睿)<sup>1,2</sup>, Zitao Zhang(张子涛)<sup>1</sup>,  
Weimin Jiang(姜伟民)<sup>1</sup>, Qiang Zhao(赵强)<sup>1</sup>, Yujie Qiao(乔宇杰)<sup>1</sup>, Meihui Chen(陈美慧)<sup>1</sup>,  
Xingyu Chen(陈星宇)<sup>1</sup>, Ruifen Dou(窦瑞芬)<sup>1,†</sup>, Changmin Xiong(熊昌民)<sup>1,‡</sup>, and Jiakai Nie(聂家财)<sup>1,§</sup>

<sup>1</sup>Department of Physics, Beijing Normal University, Beijing 100875, China

<sup>2</sup>State Key Laboratory of Luminescence and Applications, Changchun Institute of Optics, Fine Mechanics and Physics, Chinese Academy of Sciences, Changchun 130033, China

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High-quality  $\text{Sr}_2\text{CrWO}_6$  (SCWO) films have been grown on  $\text{SrTiO}_3$  (STO) substrate by pulsed laser deposition under low oxygen pressure. With decrease of the film thickness, a drastic conductivity increase is observed. The Hall measurements show that the thicker the film, the lower the carrier density. An extrinsic mechanism of charge doping due to the dominance of oxygen vacancies at SCWO/STO interfaces is proposed. The distribution and gradient of carrier concentration in SCWO films are considered to be related to this phenomenon. Resistivity behavior observed in these films is found to follow the variable range hopping model. It is revealed that with increase of the film thickness, the extent of disorder in the lattice increases, which gives a clear evidence of disorder-induced localization charge carriers in these films. Magnetoresistance measurements show that there is a negative magnetoresistance in SCWO films, which is considered to be caused by the magnetic scattering of magnetic elements  $\text{Cr}^{3+}$  and  $\text{W}^{5+}$ . In addition, a sign reversal of anisotropic magnetoresistance (AMR) in SCWO film is observed for the first time, when the temperature varies across a characteristic value,  $T_M$ . Magnetization–temperature measurements demonstrate that this AMR sign reversal is caused by the direction transition of easy axis of magnetization from the in-plane ferromagnetic order at  $T > T_M$  to the out-of-plane at  $T < T_M$ .

**Keywords:**  $\text{Sr}_2\text{CrWO}_6/\text{SrTiO}_3$ , anisotropic magnetoresistance, sign reversal, resistivity

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## 1. Introduction

Double perovskite is a large class of compounds discovered in the 1960s. Its chemical formula is  $\text{A}_2\text{BB}'\text{O}_6$ , where A is alkaline earth metal or rare earth metal ion, and B and B' are transition metal ions.<sup>[1,2]</sup> The double perovskite compound  $\text{A}_2\text{BB}'\text{O}_6$  takes transition-metal atoms B and B' as the center to form an oxygen octahedron  $\text{ABO}_3$  and  $\text{AB}'\text{O}_3$ , which alternately crystallizes in the rock salt structure along the three crystal axes. Double perovskite oxides usually have a very high Curie temperature ( $> 400$  K). High Curie temperature make double perovskite oxide a potential material for magnetoresistive devices and room temperature spintronics.<sup>[3]</sup> Fe-based double perovskite has been widely studied in the past few decades. High Curie temperatures in  $\text{Sr}_2\text{FeMoO}_6$  ( $T_C = 440$  K) and  $\text{Sr}_2\text{FeReO}_6$  ( $T_C = 401$  K) have been observed.<sup>[4,5]</sup> In 2000s, it was also discovered that the Cr-based double perovskite also has a large low-field magnetoresistance and a high Curie temperature.<sup>[6]</sup> Curie temperatures well above 600 K have been reported in the double perovskite  $\text{Sr}_2\text{CrReO}_6$  polycrystalline samples.<sup>[7,8]</sup> In the other Cr-based double perovskites, such as  $\text{Sr}_2\text{CrMoO}_6$  and  $\text{Sr}_2\text{CrWO}_6$  (SCWO),  $T_C$

above 450 K was observed.<sup>[9,10]</sup>

SCWO is a typical  $\text{A}_2\text{BB}'\text{O}_6$ -type double-perovskite oxides, where  $\text{Cr}^{3+}$  and  $\text{W}^{5+}$  occupy the B and B' sites, alternatively. Band-structure calculations reveal that they are ferromagnetic half-metals with highly spin-polarized transport properties at the Fermi level.<sup>[3]</sup> The corresponding  $T_C$  is  $\sim 460$  K.<sup>[10,11]</sup> In SCWO, there is antiferromagnetic exchange coupling between Cr and W,  $\text{Cr}^{3+}$  ( $3d^3$ ,  $s = 3/2$ ) is antiferromagnetically coupled to  $\text{W}^{5+}$  ( $5d^1$ ,  $s = 1/2$ ), giving a net spin of  $2 \mu_B$  per formula unit (f.u.).<sup>[1]</sup> These spin states can be explained by the fact that, when the magnetic field  $H$  is dominant with its large positive or negative values, all spins are aligned parallel ( $+3/2$ ,  $+1/2$ ) or antiparallel ( $-3/2$ ,  $-1/2$ ) to the  $z$  direction, respectively.<sup>[11]</sup> Moreover, W is a 5d transition metal, 4d and 5d orbits have stronger ductility compared with 3d orbits, and Coulomb repulsive potential gradually weakens in 4d and 5d. Therefore, the research process has gradually moved from 3d to 4d/5d transition metal oxides. Since the spin–orbit coupling (SOC) is proportional to the fourth power of the atomic number, the SOC intensity of 5d transition metal oxides increases to a degree comparable to the Coulomb in-

<sup>†</sup>Corresponding author. E-mail: ruifendou@bnu.edu.cn

<sup>‡</sup>Corresponding author. E-mail: cmxiong@bnu.edu.cn

<sup>§</sup>Corresponding author. E-mail: jcnie@bnu.edu.cn

teraction, and richer physical phenomena arise.<sup>[12]</sup> The SOC caused by the double exchange interaction is also considered to be one of the possible explanations for the origin of thin film anisotropy of magnetoresistance (MR).<sup>[13–15]</sup> Due to the complex coupling between charge state, spin state, lattice state and orbital state, anisotropic magnetoresistance (AMR) characteristics can be used to explore physics. AMR increases the possibility of using devices such as magnetic field sensors and magnetoresistive random access memory. Therefore, AMR has attracted widespread attention.<sup>[16–18]</sup>

In most cases, double-perovskite materials show negative MR, and only a few studies report the positive MR or even both the positive and negative MR.<sup>[19–21]</sup> Due to the parasitic phase,<sup>[21,22]</sup> the synthesis of single-phase, high-quality SCWO is very difficult. Therefore, only a few experimental works have been reported on SCWO.<sup>[6,10,21,22]</sup> Here, we report the successful fabrication of single-phase double-perovskite SCWO thin films by pulsed laser deposition (PLD). The conductivity, Hall effect, magnetization, MR, and AMR in the epitaxial SCWO thin films grown on SrTiO<sub>3</sub> (STO) (001) substrate is investigated.

## 2. Experimental details

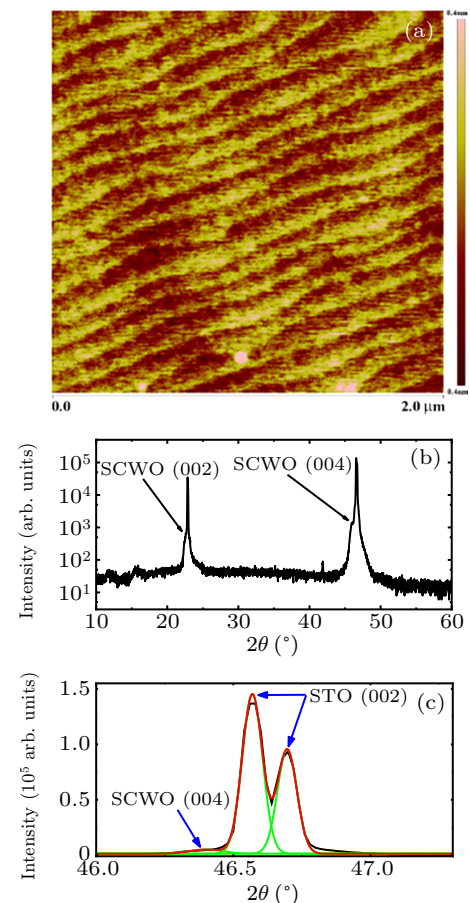
Atomically flat single-crystal TiO<sub>2</sub>-terminated (001) STO substrates were obtained by chemical etching with NH<sub>4</sub>F buffered HF solution (pH = 5.1), and subsequent were annealed at 930 °C for 2 h in a pure oxygen atmosphere.<sup>[24,25]</sup> SCWO films were grown on the annealed substrates by PLD (KrF,  $\lambda = 248$  nm), using a polycrystalline pellet SCWO target. Before each deposition, the chamber is evacuated to a vacuum of  $2 \times 10^{-8}$  Torr (1 Torr =  $1.33322 \times 10^2$  Pa). During each deposition, the substrate temperature was kept at 750 °C under oxygen partial pressures of  $1.2 \times 10^{-6}$  Torr, the laser repetition rate was 2 Hz and the laser energy density was 1.5 J/cm<sup>2</sup>.<sup>[21]</sup>

Atomic force microscope (AFM) was used to observe the surface morphology of thin films. The structural properties of the films were measured by using an x-ray diffractometer (Shimadzu XRD-6000). The electrical-transport and magnetization were carried out by using the standard four probe resistivity measurement and the vibrating sample magnetometer (VSM) module, respectively, in a physical property measurement system (PPMS, Quantum Design). Electrode contacts to the samples were bonded by ultrasonic wire bonding (Al wire of 25  $\mu$ m diameter). The DC current for the normal state measurements was 10  $\mu$ A. The temperature dependence of magnetization was also measured by using a SQUID-VSM (Quantum Design).

## 3. Results and discussion

It can be seen from Fig. 1(a) that the surface of the SCWO films is atomically flat and shows steps from the processed

STO substrate, indicating a two-dimensional (2D) nucleation and a step-flow growth mode.<sup>[26]</sup> Figure 1(b) shows the XRD pattern of a typical SCWO film deposited on a single-crystal STO(001) substrate. The film peaks appear at 22.72° and 46.40°, which are the characteristic peaks of SCWO, corresponding to (002) and (004) reflections, respectively (see Figs. 1(b) and 1(c)). The corresponding *c*-axis lattice constant is about 7.821 Å, which is well consistent with the previous report (7.82 Å).<sup>[10]</sup> For the very thin films, the mean grain size (out-of-plane) *d* is well consistent with the film thickness. The full width at half maximum (FWHM) of the most intense XRD peak (004) of SCWO is routinely used to determine *d* using the Scherrer formula,  $\lambda d = 0.9/(\text{FWHM} \cdot \cos\theta)$ , where  $\lambda$  is the wavelength of the filament used in the XRD machine,  $\theta$  is the incident angle of the same peak. The nominal thickness was usually determined by the number of laser shots and the calibrated growth rate. Four typical thin films with different thicknesses of 33.89 nm, 27.11 nm, 20.33 nm, and 13.56 nm were prepared, respectively.

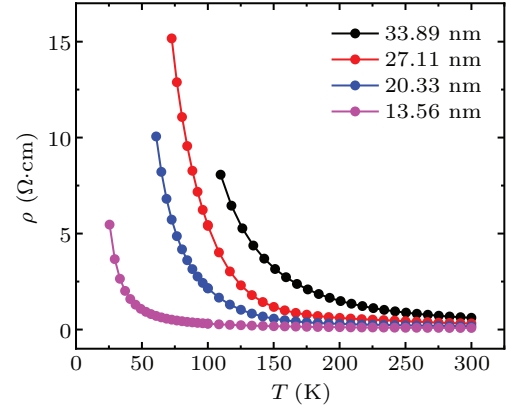


**Fig. 1.** (a) AFM image of a typical SCWO sample with thickness of 27.11 nm. (b) XRD pattern of the SCWO/STO (001) thin film in panel (a). (c) XRD-peak-differentiation analysis for SCWO (004) and STO (002) peaks.

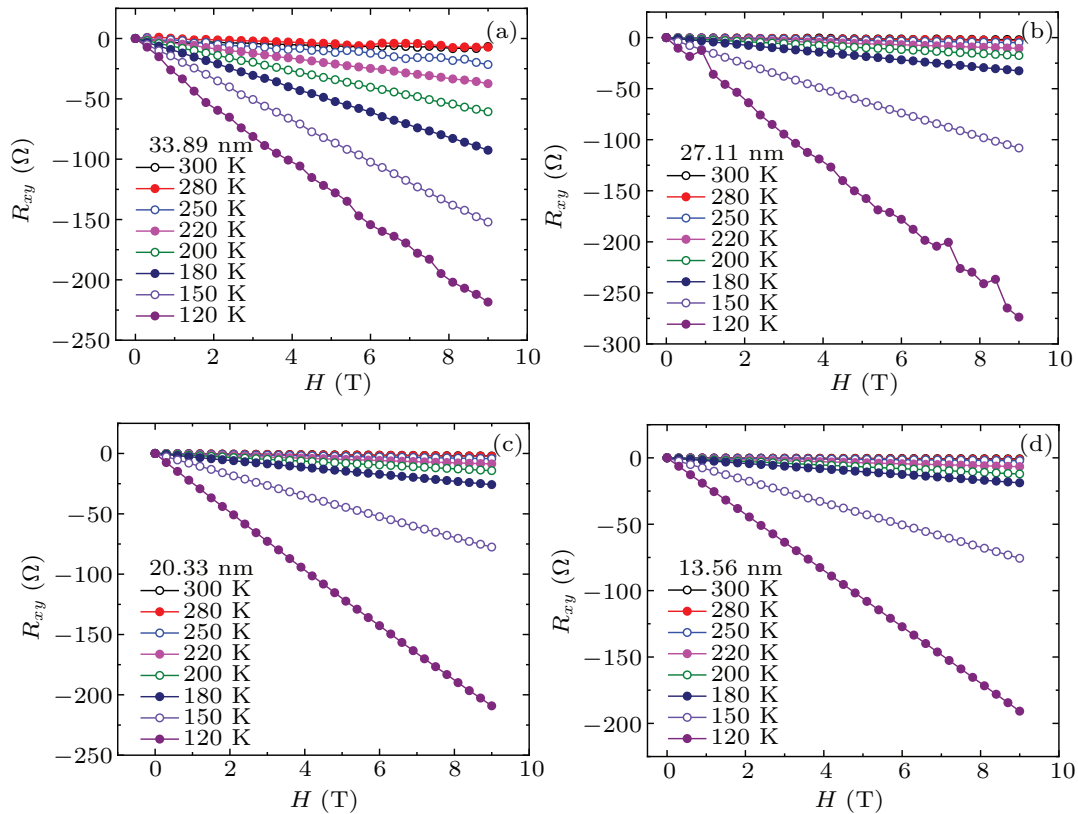
The temperature dependence of the resistivity was measured by the method of four probe without an external magnetic field, which is shown in Fig. 2. SCWO films, deposited

under low oxygen pressure ( $1.2 \times 10^{-6}$  Torr), show a semi-conducting behavior in the whole temperature range, which is consistent with previous reports.<sup>[6,20]</sup> We did not show the properties of SCWO films at lower temperatures than that shown in Fig. 2, because the film resistance at low temperatures is too large and exceeds the measurement range of PPMS, so some film data at lower temperatures are discarded. To our surprise, at the same temperatures, the thinner the sample, the less resistivity it has. This is intuitively contrary to the properties exhibited by most film samples.<sup>[27,28]</sup> Ohtomo *et al.*<sup>[29]</sup> and Kalabukhov *et al.*<sup>[30]</sup> have reported an extrinsic mechanism of charge doping due to the dominance of oxygen vacancies at LaAlO<sub>3</sub>/STO interfaces grown at lower oxygen pressures. In 2012, Pavlenko *et al.*<sup>[31]</sup> reported that oxygen vacancies at titanate interfaces induce a complex multi-orbital reconstruction. Inspired by this, we speculate through analysis that the extrinsic mechanism of charge doping caused by oxygen vacancies is dominant at the SCWO/STO interfaces grown under low oxygen pressure ( $\sim 10^{-6}$  Torr). Certainly, the intrinsic oxygen vacancies in the SCWO films may also

play a role. At the SCWO/STO sample, the abnormal dependence between resistivity and thickness might be related to the oxygen vacancies and the disorder in the sample. The thicker the film, the larger the carrier concentration distribution range and the higher concentration gradient there is, and therefore the higher the degree of disorder.



**Fig. 2.** Temperature dependence of resistivity of samples with different thicknesses. All films show semiconducting behavior in the whole temperature range. The thinner the sample, the better the conductivity.

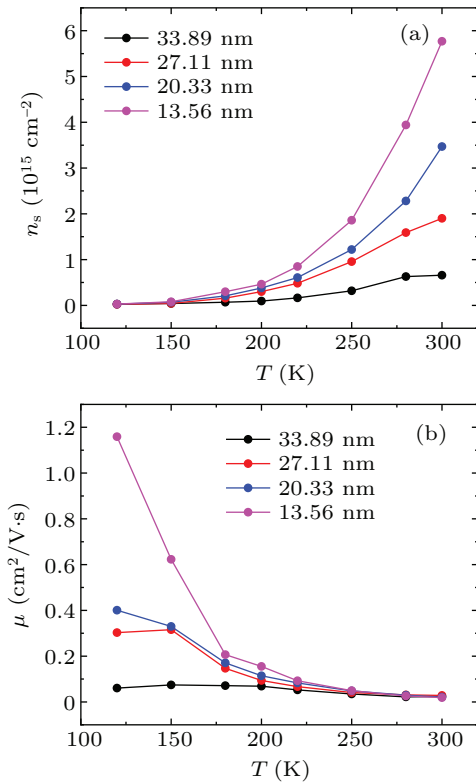


**Fig. 3.** Hall resistance of the SCWO films at different temperatures with the applied magnetic field up to 9 T. The slope of the curve is negative, indicating that the conductive carriers are electrons.

In order to confirm our conjecture, we performed the measurement of Hall transport (Fig. 3). The  $R_{xy}$  shows a linear behavior up to 9 T, the negative slope of the curves indicates that the conductive carriers in SCWO are electrons. According to the formula,  $n_s = -1/R_{He}$ , ( $e$  is the charge of an electron), the sheet carrier density  $n_s$  is obtained. The obtained sheet carrier

density  $n_s$  of the films at different temperatures is shown in Fig. 4(a). At the same temperatures, the sheet carrier density  $n_s$  decreases with increase of the film thickness. It is noteworthy that in a low temperature range of 120 K–150 K, the magnitude order of sheet carrier density is the same for all films. Although this is confusing, it is speculated that this could be

related to the recovery of oxygen vacancies with increase of the film thickness even under the same preparation conditions. According to the carrier mobility formula,  $\mu = \sigma/n_v e$  ( $\sigma$  is the conductivity,  $n_v$  is the volume carrier density), the calculated Hall mobility  $\mu$  of the films at different temperatures is shown in Fig. 4(b). We can see that at the same temperatures, the thinnest sample (13.56 nm) has the largest carrier mobility. With the increase of sample thickness, the carrier mobility  $\mu$  reduces significantly. From Fig. 4, we can also see that for the same sample, the carrier density increases with the increase of temperature, while the carrier mobility decreases with increase of temperature. Altogether, the higher the temperature, the better the conductivity.



**Fig. 4.** (a) Temperature dependence of the sheet carrier density  $n_s$  for all the SCWO films. (b) Temperature dependence of the carrier mobility  $\mu$  for all the SCWO films. We can see that the thicker the sample, the smaller the carrier density and mobility.

The great difference of the thickness dependent resistivity is attributed not only to the carrier density, but also to the carrier mobility. It should be related to the specific scattering mechanism of carriers in SCWO films. The temperature dependence of resistivity of the films can be explained in terms of Mott's variable range hopping (VRH) model.<sup>[32]</sup> According to this model, the resistivity can be expressed as

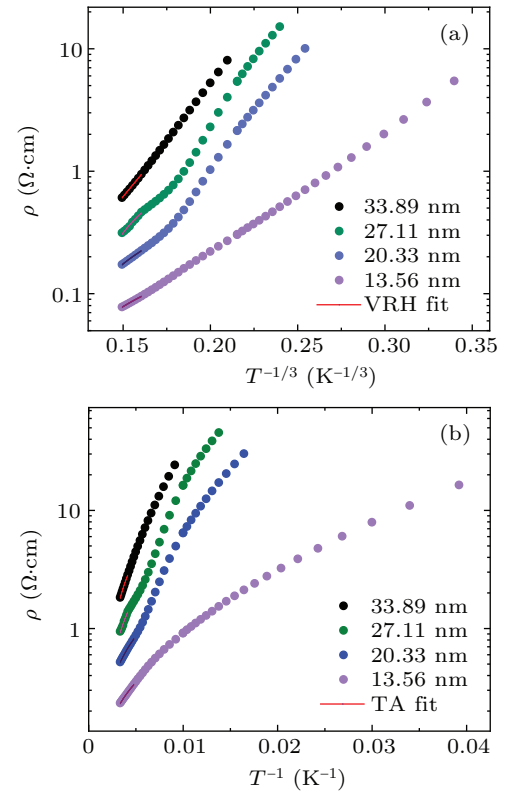
$$\rho(T) = \rho(0) \exp\left(\frac{T_0}{T}\right)^\gamma, \quad (1)$$

where the VRH exponent  $\gamma$  determines the dimensionality of the conducting medium by the relation  $\gamma = 1/(1+d)$ . For three-, two-, and one-dimensional systems, the possible values

of  $\gamma$  are 1/4, 1/3, and 1/2 respectively.  $\rho(0)$  is the resistivity at extremely high temperature,  $T_0$  is the Mott characteristic temperature, which depends on the electronic structure, and the energy distribution of the localized states.  $T_0$  can be written as<sup>[33,34]</sup>

$$T_0 = \frac{18}{k_B N(E_F) \xi^3}, \quad (2)$$

where  $k_B$  is the Boltzmann constant,  $N(E_F)$  is the density of states at the Fermi level and  $\xi$  is the localization length, *i.e.*, the average distance between Cr and W ions. In Fig. 5(a),  $\ln \rho(T)$  versus  $T^{-1/3}$  has been plotted for all the samples, which shows a linear temperature dependence in the high temperature range. Thus, a 2D charge transport mechanism is suitable for explaining the temperature dependence of resistivity of the investigated SCWO samples. In order to estimate the value of  $N(E_F)$ , we have chosen a reasonable value of the localization length  $\xi$  as,  $\sim 0.39$  nm, and then calculated  $N(E_F)$  from the slope of the lines in Fig. 5(a) using Eqs. (1) and (2), the results are shown in Table 1.



**Fig. 5.** (a) Resistivity data of SCWO films fitted by the VRH model. (b) Variation resistivity of SCWO films with temperature, fitted by the TA model. The solid lines represent the theoretical fitting.

In the simple thermally activated (TA) model,<sup>[35]</sup>  $\rho(T)$  is compared to

$$\rho(T) = \rho(0) \exp\left(\frac{W}{k_B T}\right), \quad (3)$$

where an electron moves from one localized state to another due to an exchange of energy between the charge carrier and phonon (the localization is not a consequence of interaction with a phonon, but could occur due to a random electric field



or disordered arrangement of oxygen vacancies). In Eq. (3),  $W$  is the thermal activation energy of the electron. The electrical resistivity of is replotted as  $\ln \rho(T)$  versus  $1/T$  in Fig. 5(b). Since the data do not exhibit linear behavior throughout the temperature range, we conclude that equation (3) is an inadequate description. However, this equation can provide an estimate of thermal activation energies in high temperature regions where the data can be fitted (see the Fig. 5(b)). As can be seen from Figs. 5(a) and 5(b), both the models describe the transport behavior of all the samples well at high temperature region.

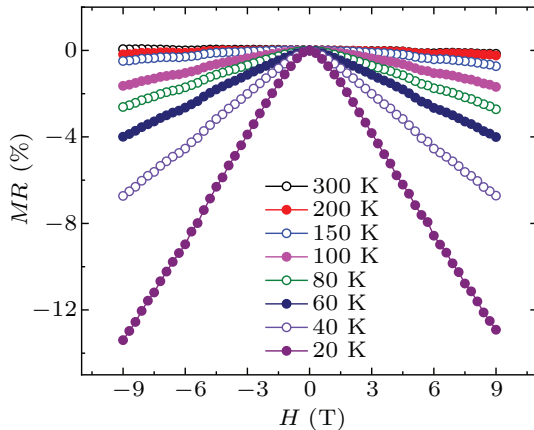
Furthermore, the mean hopping distance  $R_h(T)$  and hopping energy  $E_h(T)$  as a function of temperature are given below:<sup>[32,33]</sup>

$$R_h(T) = \frac{3\xi}{8} \left( \frac{T_0}{T} \right)^{1/4}, \quad (4)$$

**Table 1.** Physical parameters of SCWO films obtained from electrical measurements.

Thickness (nm)	$T_0$ ( $10^4$ K)	$W$ (meV)	$N(E_F)$ ( $10^{22}$ eV $^{-1}$ ·cm $^{-3}$ )	$R_h$ (300 K) (Å)	$E_h$ (300 K) (meV)
33.89	8.04	47.78	4.35	0.59	2.67
27.11	3.53	42.63	9.92	0.48	2.13
20.33	1.33	27.76	26.2	0.38	1.67
13.56	1.05	21.87	33.2	0.36	1.57

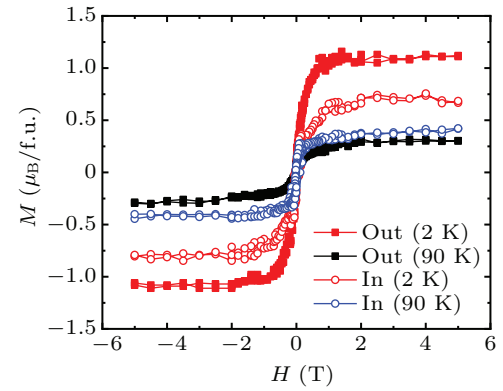
Figure 6 shows the  $MR$  at various temperatures, defined by  $MR = [\rho(B) - \rho(B=0)]/\rho(B=0)$ , as a function of magnetic field ( $B \perp$  interface).<sup>[36]</sup> It is found that SCWO films all exhibit negative  $MR$  behavior. When the external field is 9 T, the  $MR$  can reach 13.43% at low temperature (20 K). Negative longitudinal reluctance often occurs in magnetic materials, associated with spin-flip related scattering. As we have mentioned in our previous introduction,  $\text{Cr}^{3+}$  and  $\text{W}^{5+}$  are magnetic elements, and the magnetic long-range order exists in SCWO films. Therefore, SCWO exhibits negative magnetoresistance behavior.



**Fig. 6.** Out-of-plane negative  $MR$  as a function of the magnetic field  $H$  at various temperatures for the 13.56-nm-thick SCWO film.  $H$  is perpendicular to the current  $I$  and the interface.

$$E_h(T) = \frac{1}{4} k_B T^{3/4} T_0^{1/4}. \quad (5)$$

At 300 K, calculated values of  $R_h(T)$  and  $E_h(T)$  for SCWO thin films are presented in Table 1. From it, both these parameters increase with increase of the film thickness. The thermal activation energy  $W$  also increases with increase of the film thickness. While the density of states at the Fermi level  $N(E_F)$  decreases with increase of the film thickness. Hence it gives a clear indication of disorder in the system. That is, with increase of the film thickness, the extent of disorder in the lattice increases, so that the carriers are induced in delocalized states by severe potential fluctuation. This result is well consistent with the simple estimation for the disorder:  $1/\tau = e/m^* \mu$ , where  $m^*$  is the electron effective mass, and  $\tau$  is the average scattering time. As shown in Fig. 4(b), the thicker the film, the lower carrier mobility  $\mu$  and therefore the high disorder.



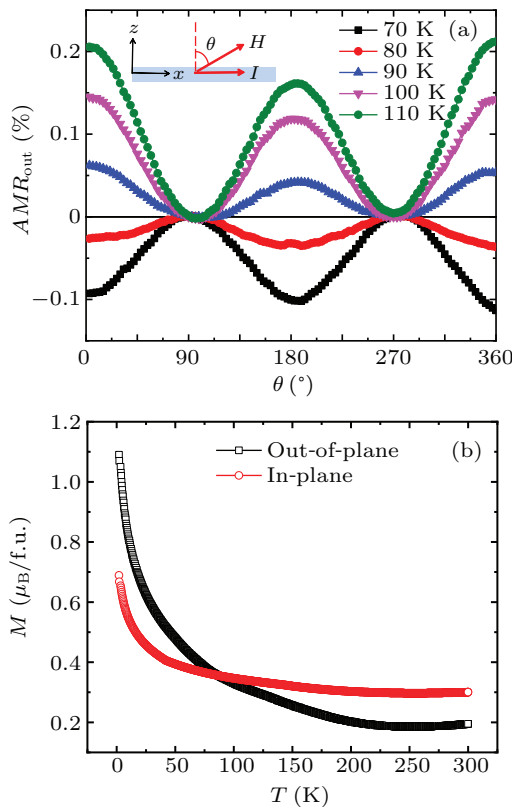
**Fig. 7.** Magnetization-magnetic field ( $M$ - $H$ ) curves of the typical SCWO film with thickness of 27.11 nm. All films show well-saturated  $M$ - $H$  loops, indicating the ferromagnetic nature.

Theoretically, the antiferromagnetic coupling between Cr ( $S = 3/2$ ) and W ( $S = 1/2$ ) makes the net magnetic moment of SCWO is  $2 \mu_B/\text{f.u.}$  along the  $c$  axis.<sup>[11]</sup> Therefore, we measured the in-plane and out-of-plane magnetization-magnetic field ( $M$ - $H$ ) curves through PPMS at 2 K and 90 K, respectively, with a magnetic field of 0 T–9 T and the results are plotted in Fig. 7. As shown in Fig. 7, out-of-plane  $M$ - $H$  curves show a magnetization saturation of about 1.1 (0.3)  $\mu_B/\text{f.u.}$  at 2 K (90 K) in the field higher than 2 T, which is a little smaller than the theoretical valuation due to the anti-site defects (between Cr and W) and/or the oxygen vacancies. In-plane  $M$ - $H$  curves show a magnetization saturation of about 0.7 (0.4)  $\mu_B/\text{f.u.}$  at 2 K (90 K) in the field higher than 2 T,

which is well consistent with the magnetization-temperature measurements (see Fig. 8(b)).

Figure 8(a) shows AMR of the thin film as a function of the angle  $\theta$  from  $0^\circ$  to  $360^\circ$ . As is shown in the inset of Fig. 8(a),  $\theta$  is the angle between the out-of-plane magnetic field and the in-plane current  $I$ .  $\theta = 0^\circ$  corresponds to the configuration of  $H$  perpendicular to the plane of the film ( $H \perp I$ ), and  $\theta = 90^\circ$  corresponds to  $H$  parallel to the plane of the film ( $H \parallel I$ ) (see Fig. 8(a)). Here, AMR is defined as

$$AMR = \frac{\rho(\theta) - \rho(90^\circ)}{\rho(90^\circ)} \times 100\%.$$



**Fig. 8.** (a) AMR for the 27.11-nm-thick SCWO/STO (001) film, in applied field of 9 T. AMR for thin films plotted in linear coordinates with angle  $\theta$  swept forward and backward ( $0^\circ$ – $360^\circ$ – $0^\circ$ ). Inset: schematic diagram of AMR measurement, where  $\theta = 0^\circ$  corresponds to the direction of magnetic field  $H$  is perpendicular to the interface and the angle  $\theta$  between the magnetic field direction  $H$  and  $z$  axis is varied. (b) Out-of-plane and in-plane ZFC magnetizations as a function of temperature ( $T$ ) in applied field of 7 T for the SCWO/STO thin film in panel (a).

The AMR changes periodically with the angle  $\theta$ , showing a two-fold  $\cos^2 \theta$  dependence at high temperatures. Moreover, the AMR flips and changes sign as the temperature is lower than 90 K (see Fig. 8(b)). Such kind of AMR signal flip has never been reported in the SCWO system. This phenomenon indicates that there is a magnetic transition in the temperature between 80 K and 90 K. Therefore, we further used SQUID-VSM to measure the in-plane and out-of-plane magnetization-temperature ( $M$ – $T$ ) curves of the film at magnetic field of 7 T (maximum magnetic field in SQUID-VSM), the zero field cooling (ZFC) results are shown in the Fig. 8(c).

For the applied magnetic field of 7 T,  $M_{\text{in-plane}}$  is found to be less than  $M_{\text{out-of-plane}}$  at temperatures below  $T_M \sim 86$  K. While above  $T_M$ , the  $M_{\text{in-plane}}$  is greater than the  $M_{\text{out-of-plane}}$ . Therefore, we clearly observed the reversal behavior of AMR at  $T_M \sim 86$  K. With the decrease of temperature, the easy axis of magnetization reverses from in-plane for  $T > T_M$  to out of plane for  $T < T_M$ . At present, there is no clear understanding as to the reason for the change of the easy axis of magnetization. One possibility is the strain induced rotation of the magnetization easy axis. The strain originates from the difference in lattice constant between the film and the substrate.<sup>[18,37,38]</sup> SCWO/STO samples have an epitaxial strain of +0.128% in the plane of the film, since SCWO has an in-plane lattice constant  $a = 3.91$  Å and STO substrate has a lattice constant of 3.905 Å. There is another possibility that because the overall expansion of  $c$  decreases with increasing temperature, the reversal of the easy axis of magnetization is caused by the competition between the shape anisotropy and the inherent magneto-crystalline anisotropy.<sup>[39]</sup>

## 4. Conclusion

In summary, we have successfully prepared high-quality SCWO films by PLD under low oxygen pressure. All the samples show semiconducting behavior. With increase of the film thickness, a drastic resistivity increase is observed. The Hall measurements show that the thicker the film, the lower the volume carrier density. An extrinsic mechanism of charge doping due to the dominance of oxygen vacancies at SCWO/STO interfaces is proposed. The distribution and gradient of carrier concentration in SCWO films are considered to be related to this phenomenon. Resistivity behavior observed in these films is found to follow the VRH model. It is revealed that with increase of the film thickness, the extent of disorder in the lattice increases. The present study gives a clear evidence of disorder-induced localization charge carriers in these films. Magnetoresistance measurements show that there is a negative magnetoresistance in SCWO films, which is believed to be caused by the magnetic scattering of magnetic elements  $\text{Cr}^{3+}$  and  $\text{W}^{5+}$ . In addition, a sign reversal of AMR in an SCWO film is observed for the first time, which is related to the direction transition of the easy axis of magnetization from out-of-plane to in-plane as the temperature increases. Our results are valuable for the application of oxide-spintronics.

## Acknowledgement

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